

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Koichi TERASHIMA, et al.

Title: SEMICONDUCTOR DEVICE AND

MANUFACTURING PROCESS THEREFOR

Appl. No.: 10/576,412

Filing Date: 4/19/2006

Examiner: Allan R. Wilson

Art Unit: 2815

Confirmation

3430

Number:

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated April 14, 2009, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 8 of this document.

Please amend the application as follows: